



1 Article

# Measurement of 3D Ultrasonic Wavefield Using Pulsed Laser Holographic Microscopy for Ultrasonic Nondestructive Evaluation

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12 Abstract: In ultrasonic array imaging, 3D ultrasonic wavefields are normally recorded by an 13 ultrasonic piezo array transducer. Its performance is limited by the configuration and size of the 14 array transducer. In this paper, a method based on digital holographic interferometry is proposed 15 to record the 3D ultrasonic wavefields instead of the array transducer, and the measurement system consisting of a pulsed laser, ultrasonic excitation, and synchronization and control circuit 16 17 is designed. A consecutive sequence of holograms of ultrasonic wavefields are recorded by the 18 system. The interferograms are calculated from the recorded holograms at different time sequence. 19 The amplitudes and phases of the transient ultrasonic wavefields are recovered from the 20 interferograms by phase unwrapping. The consecutive sequence of transient ultrasonic wavefields 21 are stacked together to generate 3D ultrasonic wavefields. Simulation and experiments are carried 22 out to verify the proposed technique, and preliminary results are presented.

Key words: digital holographic microscopy; CCD sensor; array transducer; ultrasonic wavefield;
 ultrasonic imaging

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## 26 1. Introduction

27 In many industries such as automotive, aerospace, shipping and railway, ultrasonic imaging is 28 widely used for the engineers to intuitive find the defects inside workpieces<sup>[1]</sup>. An ultrasonic piezo 29 array transducer is normally used in ultrasonic array imaging, for example phase array C-scan<sup>[2,3]</sup>. 30 An array transducer is composed of multiple independent piezoelectric elements that are excited 31 according to certain rules and timing in order to adjust the focal position and steer the ultrasonic 32 beam direction [4]. The performance of phased array technology is affected by the size and 33 configuration of piezoelectric elements <sup>[5]</sup>. In this paper, a CCD sensor acting as the ultrasonic 34 receiving array overcomes many challenging issues faced by the current ultrasonic transducer 35 arrays, such as element density and element spacing and aperture, increasing the imaging 36 performance. As it is a non-contact sensing technique in the receiving phase then this could 37 circumvent problems when the surface is rough or has a complex geometry.

The optical detection techniques for ultrasound are classified into non-interferometric techniques and interferometric techniques. The former are well developed or of limited application, while the latter are more general and are presently the object of active developments<sup>[6]</sup>. The noninterferometric techniques, such as knife-edge technique, is very insensitive to vibrations but requires a good surface finish and is hardly applicable to image the 3D ultrasonic wavefield<sup>[7]</sup>.

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43 In interferometric techniques, a Michelson interferometer and other configurations based on 44 the other two wave interferometers (Mach-Zehnder, Fiseau) are normally used to receive the 45 ultrasound<sup>[8]</sup>. Ref. [9] report on the remote three-dimensional photoacoustic imaging by utilizing a 46 two-wave mixing interferometer (TWMI) and the Fourier domain synthetic aperture focusing 47 technique (FSAFT). The TWMI setup can detect rough and flat surfaces, but the imaging of the 48 sample was done by raster scanning in x and y-direction. Therefore, the technique cannot strictly 49 detect the ultrasonic wavefield with full-field and there is no advantage in the measurement of 50 high-frequency ultrasonic wavefields.

51 In recent years, the electronic speckle interference techniques have been proposed for use in 52 non-contact detection of ultrasonic signals<sup>[10]</sup>.In Ref. [11], the two dimensional ultrasonic surface 53 wave data are obtained by optical electronic speckle pattern interferometry (ESPI) techniques. The 54 speckle interference with digital phase-stepping is used to capture traveling ultrasonic Lamb 55 waves<sup>[12]</sup>. This means either that the phase to be measured should be constant over the time 56 required for acquisition of phase shifted interferograms or that compensation needs to be 57 introduced to allow a phase value to be calculated at the time of each recorded frame rather than 58 once every four frames<sup>[13]</sup>. In Ref.[14], the paper investigated the use of parallel phase-shifting 59 interferometry (PPSI) with a high-speed polarization camera for imaging a sound field in air. 60 Although the phase-shifted images are captured by a single-shot using PPSI, the sound field in the 61 opaque solid specimen was not obtained. These limitations can be a disadvantage when 62 high-frequency ultrasound need to be investigated in non-destructive testing applications.

63 However digital holography can measure phase and amplitude information directly with one hologram. Holography is a technique for recording and reconstructing static or dynamic 64 65 wavefronts. Holographic interferometry allows the comparison of wavefronts recorded at different 66 time instants<sup>[15]</sup> and has been used for vibration measurement since 1965<sup>[16]</sup>. Other applications of 67 this technique include displacement analysis of solid objects, shape measurement, and investigation 68 of the refractive-index change in transparent media<sup>[17]</sup>. Ref.[18] described a method for measuring 69 dynamic events in which digital holograms of an object are recorded on a high-speed CCD, and the 70 phases of the wavefront recorded at different times are calculated, only one image hologram is 71 needed for the phase to be determined at a given time instant<sup>[19]</sup>. Ref.[20] propose an optical voice 72 recorder based on digital holography for recording and reproducing propagating sound waves in 73 air.

In this paper, a method to record 3D ultrasonic wavefields on the basis of digital holographicinterferometry is proposed for ultrasonic non-destructive evaluation.

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# 77 2. Measurement of 3D ultrasonic wavefields using digital holographic interferometry

### 78 2.1 Theory of digital holographic interferometry

79 The amplitudes of the ultransonic wavefield are a few nanometers to a few microns. When the 80 ultrasonic wavefield are measured, the speckle field will cover the amplitudes. The amplitudes and 81 phases of the ultrasonic wavefield are difficult to be obtained with digital hologram technique due to 82 the tiny amplitudes. But digital holographic interferometry can be used to measure phase change 83 from speckle field<sup>[21]</sup>. According to holographic interferometry theory <sup>[22]</sup>, the first hologram is 84 collected when the surface of test piece is stationary, and the second hologram is collected when the 85 test piece is slightly displaced or excited. Based on the phase information provided by the two 86 holograms, the interferogram of the surface of test piece can be calculated. Then, the ultrasonic 87 wavefield can be obtained from the interferogram<sup>[23]</sup>.

88 Setting the wave intensity distribution to a constant value, the phase distribution only changes
89 when the surface of test piece deforms. In the first exposure (t=t1), the corresponding light intensity
90 (object light and reference light) distribution on the CCD is

$$I_{1}(x, y) = |O_{1}(x, y) + R(x, y)|^{2}$$
(1)

$$O_{1}(x, y) = O_{0}(x, y) \exp\left[-j\phi_{01}(x, y)\right]$$
(2)

$$R(x, y) = R_0 \exp\left[-j\phi_R(x, y)\right]$$
(3)

91 where  $O_1(x, y)$  represents the object light and  $O_0(x, y)$  represents intensity of object light 92 and  $\phi_{01}(x, y)$  represents the phase distribution of object light . R(x, y) represents the reference 93 light and  $R_0$  represents intensity of object light,  $\phi_R(x, y)$  represents the phase distribution of object 94 light. Setting the exposure time of the hologram (t1) as  $T_1$ , the photometric exposure is

$$H_1 = I_1 T_1 = |O_1(x, y) + R(x, y)|^2 T_1$$
(4)

95 In the second exposure (t = t2), the intensity distribution of the object light  $O_0(x, y)$  remains 96 unchanged, and the phase distribution  $\phi_{01}(x, y)$  change to  $\phi_{02}(x, y)$  in the second exposure.

$$O_{2}(x, y) = O_{0}(x, y) \exp\left[-j\phi_{02}(x, y)\right]$$
(5)

97 If the reference light R(x, y) remains unchanged, the light intensity distribution on the CCD is

$$I_{2}(x, y) = |O_{2}(x, y) + R(x, y)|^{2}$$
(6)

98 where  $O_2(x, y)$  is the object light in the hologram (t2). Setting the exposure time of the 99 hologram (t2) to  $T_2$ , the corresponding photometric exposure is

$$H_2 = I_2 T_2 = |O_2(x, y) + R(x, y)|^2 T_2$$
(7)

100 The total exposure volume is

$$E = H_1 + H_2 = \left| O_1(x, y) + R(x, y) \right|^2 T_1 + \left| O_2(x, y) + R(x, y) \right|^2 T_2$$
(8)

101 When reconstructing *E* with reference light R(x, y) in Eqs.(3), the '+1' diffracted light can be 102 described as

$$I_{3} = \beta(T_{1}O_{1} + T_{2}O_{2})RR^{*}$$
  
=  $\left(\beta |R|^{2} |O_{1}O_{2}|\right)^{2} \left\{T_{1}^{2} + T_{2}^{2} + 2T_{1}T_{2}\cos\Delta\phi(x, y)\right\}$  (9)

$$\Delta \phi(x, y) = \phi_{02}(x, y) - \phi_{01}(x, y)$$
(20)

103  $\Delta \phi(x, y)$  is the change in phase distribution between  $O_2(x, y)$  and  $O_1(x, y)$ .  $\beta$  is a real 104 constant.

105 By setting

$$W_{3} = \left(\beta \left|R\right|^{2} \left|O_{1}O_{2}\right|\right)^{2} (T_{1}^{2} + T_{2}^{2})$$
(11)

$$V_3 = \frac{2T_1T_2}{T_1^2 + T_2^2} \tag{12}$$

106 We have

$$I_{3} = W_{3} \{ 1 + V_{3} \cos \Delta \phi(x, y) \}$$
(13)

107 where  $V_3 = 1$  corresponds to the optimum fringe contrast. To get the optimum fringe 108 contrast, according to Eq. (9), make the two exposure times equal:  $T_1 = T_2$  <sup>[23]</sup>. The interferogram 109 of ultrasonic wavefield at t2 moment can be described as

$$I_3 = 2W_3 \cos^2 \left[\frac{\Delta \phi(x, y)}{2}\right]$$
(34)

According to Eqs.(14), the information of ultrasonic wavefield at t2 are embedded in the
interferogram. The ultrasonic wavefield at t2 moments can be recovered from the interferogram
through phase unwrapping (details can be found in section 4).

### 113 2.2 Measurement of 3D ultrasonic wavefields



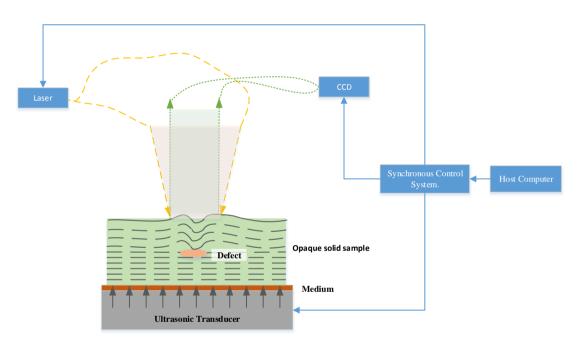


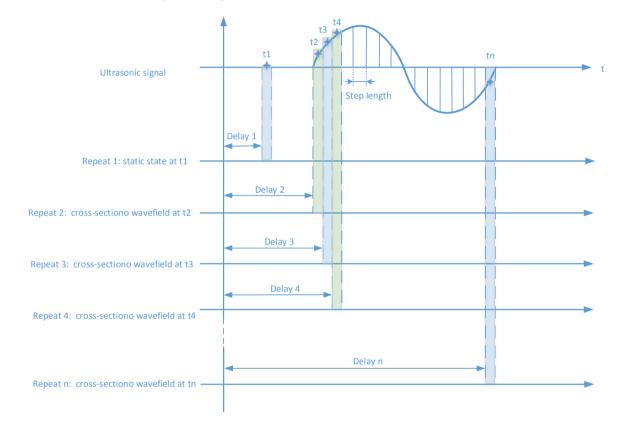


Figure 1. Schematic diagram of the proposed measurement method

117 In this paper, a method based on digital holographic interferometry is proposed to record 3D ultrasonic wavefields instead of the array transducer for imaging the internal defects of test piece. As 118 119 shown in Figure 1, this technique works as follows: an opaque solid sample is put on top a piezo that 120 generates a single frequency short pulse ultrasonic wave, and the ultrasonic wave propagates to the 121 sample surface. These ultrasonic wavefields carry information about the internal structures and the 122 internal defects. Then the dynamic ultrasonic wavefield on the surface is measured by a lensless 123 CCD camera. 3D ultrasonic data are captured by recording multiple ultrasonic wavefields at a 124 consecutive time sequence by synchronizing the CCD capture, pulsed laser irradiation and 125 ultrasonic transducer excitation.

By shifting the delay time between the ultrasonic excitation and CCD capture, and repeating the optical measurement, the cross-sectional wavefields at different depths of the test sample can be recorded. The time sequence of ultrasonic wavefields form two 3D arrays (two spatial dimensions + depth): a phase array and an amplitude array. The spatial dimensions of 3D ultrasonic wavefields 130 are determined by the number of elements on the CCD camera. Each element of the CCD camera 131 captures an equivalent ultrasonic A-scan signal. The sampling frequency for acquiring these 132 ultrasonic A-scan signals is determined by the step length of the time delay shifting shown in Figure 133 2. The minimum step length is the length of the laser pulse. If the step length is less than the laser 134 pulse length, two measured wavefields will be overlapped, and thus will reduce the accuracy of the 135 wavefield measurement. Therefore, the laser pulse width determines the upper limit of sampling 136 frequency for the A-scan signal acquisition using the optical measurement. In addition, the 137 repetition rate of the pulsed laser and the frame rate (fps) of the high-speed camera determine the 3D

138 ultrasonic wavefields acquisition speed.

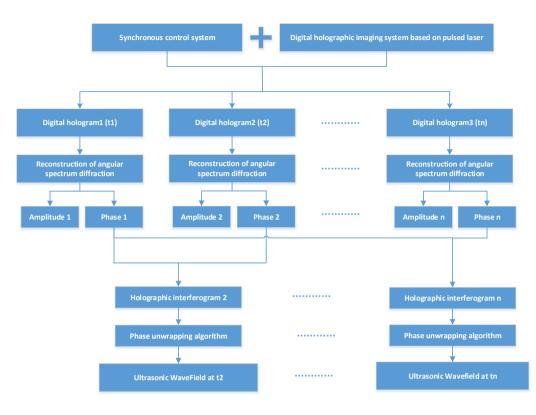


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Figure 2. Acquisition of 3D ultrasonic wavefields consisting of multiple cross-sectional wavefields.

142 As shown in Figure 2, t1, t2, t3 ... are the different time points in an ultrasonic signal. The Delay 143 1 in the Figure 2 is the delay time at first measurement (Repeat 1). At t1, the sample has not yet been 144 excited by the ultrasonic signal, and the corresponding hologram is to measure the topographical 145 surface of the test piece in the static state. t2 .... tn are the sampling points of the dynamic ultrasonic 146 wavefields. By shifting the delay time (Delay 2) in second measurement (Repeat 2), the cross-section 147 wavefield at t2 is obtained. Delay 3.... Delay n are the delay time at t3 .... tn moment and the different 148 delay times are based on the cross-sectional wavefields at different depths. As shown in Figure 2, 149 each repeated measurement will set a delay time and the corresponding ultrasonic wavefields will 150 be obtained.





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Figure 3. Flow chart of measurement of 3D ultrasonic wavefields

153 Figure 3 shows an analysis of *n* points. As shown in Figure 3, the digital holograms of the test 154 sample are obtained at times t1, t2 ... tn. The specimen surface at t1 is stationary. According to theory 155 of digital holographic interferometry(in section 2.1), the interferograms 2 to *n*-1 of the ultrasonic 156 wavefields at t2 to tn relative to t1 can be obtained. Holographic interferogram2 in Figure 3 is linked 157 to Eqs.(9). As shown in Figure 3, the angular spectrum reconstruction is used to obtain the amplitude 158 and phase of the light field. The angular spectrum method have several advantages over the more 159 commonly used Fresnel transformation or Huygens convolution method. Spurious noise and 160 interference components can be tightly controlled and the reconstruction distance does not have a 161 lower limit. The off-axis angle between the object and reference can be lower than the Fresnel 162 requirement and still be able to cleanly separate out the zero-order background<sup>[24]</sup>. These 163 interferograms are then used to generate the cross-sectional wavefields at time instants of t2 to tn.

## 164 3. Design of 3D Ultrasonic Wavefields Measurement System

In order to obtain the interferograms in Figure 3, a pulsed digital holographic microscopysystem is designed as shown in Figure 4.

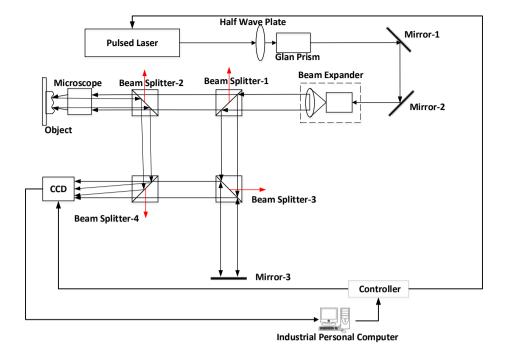




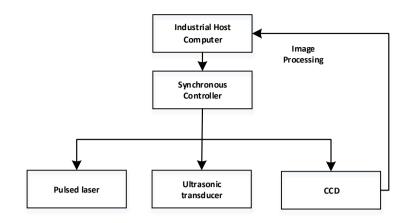


Figure 4. The designed pulsed digital holographic microscopy system

169 First, the pulsed light beam passes through the half-wave plate and Glan prism. They can both 170 control the energy of the light beam and ensure a pure polarized light beam, improving the 171 efficiency of the pulsed light beam interference. Then, the light beam passes through the beam 172 expander and enters beam splitter-1. The coherence distance of the plused laser is limited. In order to 173 ensure that the light path of the reference light and the object light are the same, the Mirror-3 in Fig. 4 174 is used to make up the light path difference. The specimen is an opaque solid and the reflected object 175 light is weak when the reflectivity of the target specimen is low. To facilitate the ratio of intensity 176 between the reference beam and object beam, we chose a 9:1 non-polarizing beam splitter cube 177 (NPBS) as beam splitter-1. The NPBS used here is 90% of the transmitted light and 10% of the 178 reflected light, which enhances the intensity of the object light and weakens the intensity of the 179 reference light. It is also helpful to tune the ratio of the object light to the reference light, improving 180 the hologram quality. Because the pulsed light beam is pure polarized light, we chose the rest of the 181 beam splitters to be NPBS, but with a splitter ratio of 5:5. As shown in Figure 4, the object is placed 182 near beam splitter-2, and mirror-3 is placed near diagonal beam splitter-3. The four beam splitters in 183 Figure 4 reflect the unwanted light beam out of the light path, as shown by the red arrow.

184 The parameters of the pulsed laser, camera and microscopic lens are crucial for acquiring high 185 quality 3D ultrasonic wavefields. The laser power should provide sufficient light flux to illuminate 186 the sample surface, satisfying the flux demand of the CCD camera. Coherence length of the laser 187 pulse is also important. A large coherence length will greatly facilitate the construction of the digital 188 holographic microscopy subsystem. Important parameters for the high-speed camera include the 189 shutter speed, CCD camera sensitivity and signal to noise ratio (SNR) and the frame rate. Short 190 shutter time, high sensitivity and SNR of the CCD camera ensure capturing a high quality optical 191 hologram even when limited light is provided by a short laser pulse. The performance of the 192 microscopic lens not only reduces the optical aberration, but also the magnification and numerical 193 aperture will affect the lateral resolution of the instrument. The larger the magnification, the smaller 194 the imaging region, but with a higher lateral resolution. In this paper, the pulsed laser chosen here is 195 Beamtech NIMMA 400 Pulsed Laser with a pulse width of 8 ns and the repetition rate of 1-10 Hz. 196 The wavelength of 532nm is used in the experiments. If the detected frequency of ultrasonic 197 wavefield is 1MHz, and the time period of 1000ns. The 8ns pulse width of the laser can illuminate 198 one cycle of 1/125 for its 1000ns cycle. In other words 8ns << 1000ns, can be regarded as relatively 199 transient. The CCD (German PCO Company 1600) with the shortest exposure time is chosen, and its

- 200 exposure time can be as short as 500ns. The frame rate of CCD is 30 fps. The microscopic lens used in
- this paper is Japan Mitutoyo company, its numerical aperture NA = 0.5, the magnification of 50X.



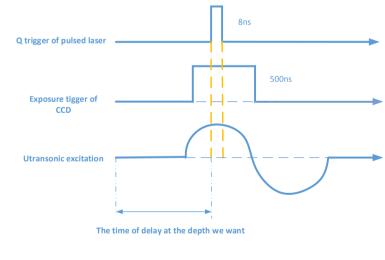
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Figure 5. Schematic of the synchronous control system.

Control and synchronization is fundamental for high-quality hologram capture. The control system must provide a precise delay time between the laser pulse and the camera capture for the proposed digital holographic microscopy system. Figure 5 shows the synchronous control system, consisting of a host computer, a synchronous controller, ultrasonic transducer, a CCD camera, and a pulsed laser. The synchronous controller is implemented through the timing of NI's PXI-6602 and digital I/O modules. As shown in figure 6, the synchronous controller is designed to ensure that the CCD camera receives the 8-ns laser pulse within its exposure time window of 500 ns, and it is also

the time when the cross-section wavefield at the depth we want.



213 214

Figure 6. Synchronous control timing diagram

215

### 216 4. Simulation Study

In this section, computer simulation is carried out to verify the feasibility of the proposedmeasurement method.

219 4.1 Simulation of Interferograms of Ultrasonic Wavefield

The interferograms of dynamic ultrasonic wavefield are simulated by computer-generated
 hologram. Here, t1 is static, and a Gaussian distribution is used to simulate the deformation of the
 surface at the time point t2.

- As shown in Figure 7, the maximum deformation of the surface caused by ultrasonic wavefield
- is z = 115 nm at t2. The wavelength of the simulated light source is  $\lambda = 0.532 \times 10^{-3}$  nm. The
- pixel width of the CCD is  $pix=7.4\mu m$ . The angle between the reference light and the object light is
- 226  $\pi/4$ . The distance between the object light and the reference light has been considered in the Figure
- **227** 4. Therefore the factor is not considered in the simulation section.

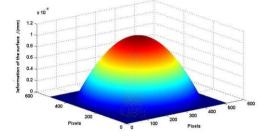
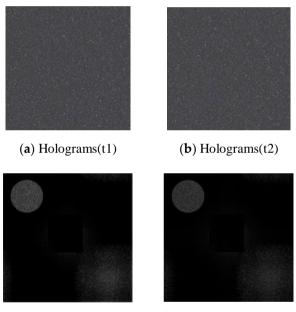




Figure 7. Surface of a longitudinal ultrasonic transducer



(c) Reconstructed plans(t1) (d) Reconstructed plans(t2)

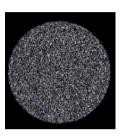
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Figure 8. The holograms before and after deformation

231 Using Fresnel diffraction theory, the object light reaching the hologram plane is simulated, and 232 the reference light is defined. Also, the interference between the object light and reference light is 233 simulated. The corresponding interference field intensity is calculated, and the digital holograms are 234 formed. Using Eqs. (1) and (3), the holograms at t1 and t2 are obtained, as shown in Figure 8. Figure 235 8(a) is the hologram at t1, and Figure 8(b) is the hologram at t2. Based on these holograms, the two 236 holograms from the angular spectrum diffraction are reconstructed. By using the angular spectrum 237 transfer function in analytic form, the calculation required only one direct and one inverse FFT. The 238 angular spectrum formula also rigorously satisfies the scalar wave equation, and its use is 239 widespread in holography. Figures 8(c) and (d) shows the reconstructed plans, and the zero-order 240 diffraction light is filtered out. After reconstructing the digital holograms, the reconstructed images 241 of the model at t1 and t2 are obtained, as shown in Figure 9. 242



(a) Amplitude of reconstruction image(t1)





(**b**) Phase of reconstruction image (t1)

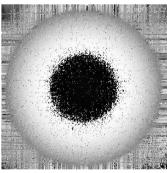


(c) Amplitude of reconstruction image (t2) (d) Phase of reconstruction image (t2)

### 244

Figure 9. Reconstructed images before and after deformation

245 Figures 9 (a) and 9 (c) show the amplitudes of the reconstructed image at t1 and t2, and these represent the shape of the speckled object. Figures 9 (a) and (c) show that, 115nm is less than the 246 wavelength of the illumination light. Therefore, the phase of the optical wave field is represented by 247 248 the arc tangent function and varies in the range of  $[-\pi,\pi]$ . In fact, the real phase takes a value of  $2\pi$ , 249 which remains a random variable. Therefore, the phase shown in Figure 9(b) and (d) is a random 250 distribution, and the deformation cannot be directly detected from the phase image. According to 251 Eqs. (5) and (6), the digital interferogram of the object light field at t2 relative to t1 as shown in Figure 252 10, can be calculated.



253 254

Figure 10. Digital interferogram of the object light field at t2 moment

The deformation is wrapped in the black and white stripe of the interferogram, and it is verified that the digital holographic interferometry can effectively measure the ultrasonic wavefield

257 4.2 Phase unwrapping in measurement of 3D ultrasonic wavefields

The ultrasonic wavefields are obtained by phase unwrapping because the absolute value of thephase change is wrapped in the interferogram.

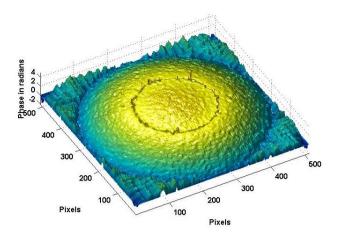
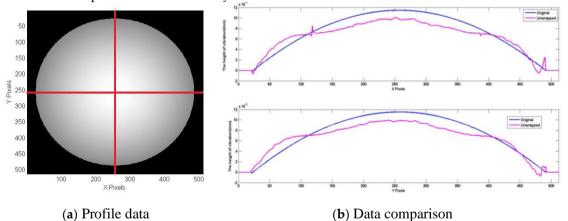


Figure 11. Phase image after unwrapping

262 2D-SRNCP unwrapping algorithm <sup>[23]</sup> is used to process the unwrapping phase. The algorithm
 263 sorts by reliability, following a non-continuous path, and copes excellently with the noise that
 264 corrupts the real wrapped phase images.

265 Figure 11 shows the true deformation of the phase in figure 10 after using the 2D-SRNCP 266 algorithm. As shown in Figure 11, some of the points after unwrapping are different from those of 267 the initial model. Because the reconstruted object wave field is a speckle field, the amplitude and 268 phase of the interferogram is subject to external constraints and perturbation. This random noise 269 affects the quality of the image and the results of the unwrapping algorithm. The 2D-SRNCP 270 algorithm is mainly based on sorting by reliability to solve the phase-wrapping. The error points in 271 Figure 11 are mostly low reliability, and the noise more seriously affects the unwrapping algorithms 272 of these points, so annular irregularities appear. The optimized unwrapping algorithm will be 273 studied for error points in the next study.



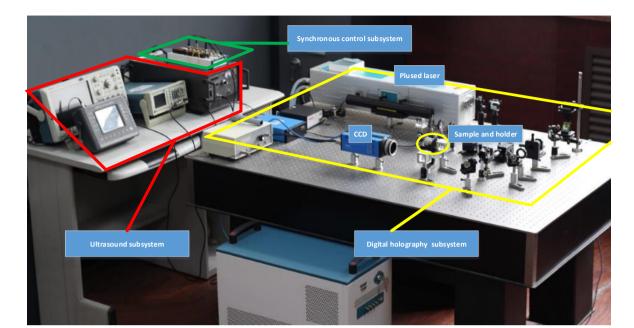
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Figure 12. Phases of deformation

To analyze the data more clearly, the one-dimensional profile data (X and Y directions) of the initial model and the unwrapped phases are obtained separately. As shown in Figure 12 (a), the profile data (red line) is selected in the image. The profile data are matched to the three-dimensional data, and the phase data of the profile data are obtained, as shown in figure 11(b). It can be confirmed again that the phase after unwrapping conforms to the initial model of vibration deformation. Comparing the two sets of curves shows that the greatest error is near the center of the circle. The maximum error is 0.28 µm, about 18%.

There is also a case when the phase is not wrapped at all, that is, when the height of the deformation is close to several or several tens of nanometers, there is no need for unwrapping.

### 284 5 Experimental Results



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Figure 13. The proposed 3D Ultrasonic Wavefields measurement system

Figure 13 shows the proposed 3D Ultrasonic Wavefields measurement system. The subsystem of digital holography consists of the CCD, the plused laser, and some optical components, which form the off-axis digital holographic optical path in Figure 4. The ultrasound subsystem consists of arbitrary waveform generator, power amplifier and ultrasonic transducer.

294 A preliminary experiment was carried out to verify the designed system. Dynamic ultrasonic 295 wavefield generated by a piezoelectric ceramic sheet was measured using the designed system. A 296 fixed piezoelectric ceramic sheet with a diameter of 25 mm, thickness of 0.2 mm, and frequency of 297 2700 Hz is used. The CCD pixel size is  $\Delta x \times \Delta y = 7.4 \mu m \times 7.4 \mu m$ , and it has a pixel resolution of 298  $1200 \times 1200$ . Because we used large specimens, we used a lens with an f = 80mm focal length 299 instead of a high-power microscope to reduce the large spot size to fit the CCD. The distance from 300 the sample to the CCD is 400 mm, the distance from the microscope to the image is 100 mm, and the 301 imaging reduction ratio is 4. The frequency of the detected vibration is 2700 Hz, the period of the 302 vibration is 370000 ns, and the 8-ns pulse width of the pulsed laser is much less than 370000 ns, 303 therefore it is transient.

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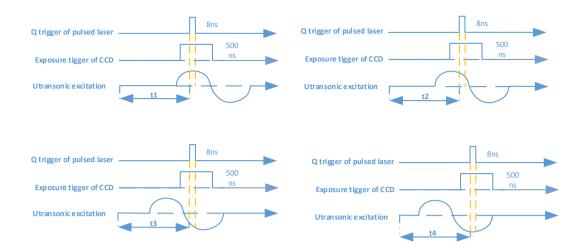
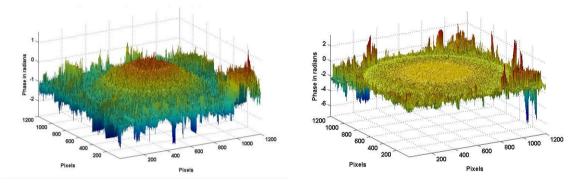




Figure 14. Synchronous control timing diagram in the experiment

309 As shown in Figure 14, the dynamic ultrasonic wavefields at four different time instants are 310 measured in this preliminary study. Four different time delays (t1,t2,t3,t4) are set up to obtain 311 different ultrasonic wavefields ..

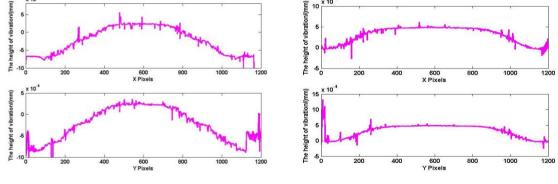


(a) Maximum surface topography at t1 moment

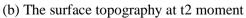
(b) The surface topography at t2 moment

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Figure 15. The surface topography at t1 and t2 moment



(a) Maximum surface topography t1 at moment



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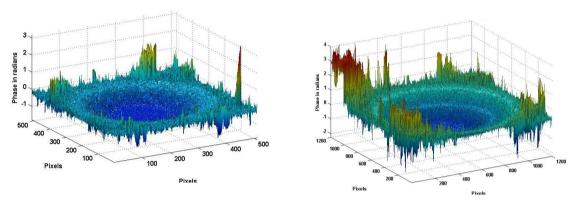
## Figure 16. Data comparison at t2 and t3 moment

314 Figure 15 shows the wavefield at the transducer surface when the transducer is vibrating to the 315 t1 moment and t2 moment , and t1 moment have the positive maximum amplitude. Due to the 316 serious interference caused by stray light in the experiment, we used an initial median filter to

mitigate interference from noise. As shown in Figure 12 (a), the cross-section (X direction and Y direction) is selected from the phase shown in Figure 16, and the results are shown in Figure 15. As shown in Figure 16 (a), the maximum amplitude is 0.89  $\mu$ m. As shown in Figure 16 (b), the amplitude at t2 moment is 0.48  $\mu$ m.

Figure 17 and 18 shows the surface topography when the amplitude in the reverse direction. The process of data processing is the same as t1 and t2 moment. Figure 17 (a) is the surface topography at t3 moment, and figure 17 (b) is the surface topography at t4 moment. The cross-section (X direction and Y direction) data are shown in Figure 18. The amplitude is 0.59 μm at t3 moment, and the maximum amplitude is 0.91 μm at t4 moment.

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(a) The surface topography at t3 moment

(b) Maximum surface topography at t4 moment

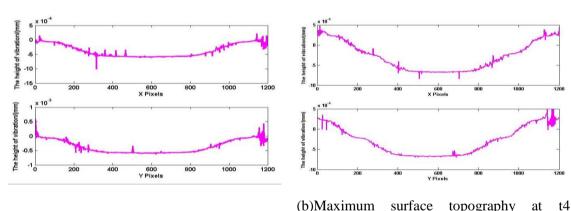
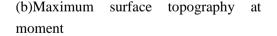


Figure 17. The surface topography at t3 and t4 moment

(a) The surface topography at t3 moment



### 328

Figure 18. Data comparison at t3 and t4 moment

329 In order to verify the measurement data, the traditional time-averaged method is used to 330 measure the same piezoelectric ceramic sheet. Because the frequency of the ultrasonic wavefilds in 331 the preliminary experiment is low, the vibration of the piezoelectric ceramic sheet could be 332 measured by the time-averaged method. The optical subsystem in the designed system is used, and 333 the pulsed laser is replaced by a continuous laser. Under the same experimental parameters, the 334 amplitude of the vibration obtained by the time-averaged method is 0.75µm.The time-averaged 335 method measures the average of the vibration of the ultrasonic wavefields, and the method 336 proposed in this paper measures the amplitude of the transient ultrasonic wavefields.

337 6 Conclusion

327

338 In this paper, the optical detection techniques acting as the ultrasonic receiving array for 339 ultrasonic imaging in order to overcome the challenging issues faced by the current ultrasonic 340 transducer arrays. The method based on holographic interferometry is proposed to measure the 341 dynamic ultrasonic wavefields, and the pulsed digital holographic microscopy system is designed. 342 The consecutive sequence of interferograms of ultrasonic wavefilds are calculated from the 343 holograms, which are recorded at different time sequence by the system. The phase unwrapping is 344 used to recover the deformation distribution of transient wavefileds from the interferograms. The 345 computer simulation verified the feasibility of the proposed measurement method. In the 346 experiment, the pulsed digital holographic microscopy system has been used to capture and 347 measure dynamic ultrasonic wavefield generated by a piezoelectric ceramic sheet. The experimental 348 results also verified the feasibility of the proposed method.

349

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